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CONFIRMATION NO. 6107

SERIAL NUMBER 10/660,609	FILING DATE 09/12/2003 RULE	CLASS 438	GROUP ART UNIT 2829	ATTORNEY DOCKET NO. 57810-075	
APPLICANTS  Naoya Sotani, Mizuho-shi, JAPAN; <i>S.B.G.</i> Isao Hasegawa, Gifu-shi, JAPAN; <i>S.B.G.</i>					
** CONTINUING DATA *****  <i>NONE S.B.G.</i>					
** FOREIGN APPLICATIONS *****  JAPAN JP2002-270939 09/18/2002 <i>S.B.G.</i>					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/02/2003					
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged Examiner's Signature <i>Leto-13</i>	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Initials <i>S.B.</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 2
ADDRESS McDERMOTT, WILL & EMERY 600 13th Street, N.W. Washington , DC 20005-3096					
TITLE Method of fabricating semiconductor device and system of fabricating semiconductor device					
FILING FEE RECEIVED 786	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )			